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PATENT  
ATTORNEY DOCKET NO. 07977/218001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Ohtani, et al.  
Serial No.: 09/006,844  
Filed : December 29, 1997  
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

Art Unit:  
Examiner:

Commissioner of Patents and Trademarks  
Washington, DC 20231

TRANSMITTAL OF PRIORITY DOCUMENT(S) UNDER 35 U.S.C. 119

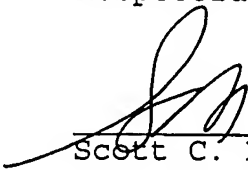
Applicants hereby confirm their claim of priority under 35 U.S.C. 119 from Japanese Application Nos. 9-022077 filed January 20, 1997, and 9-123088 filed April 26, 1997. Certified copies of the applications from which priority is claimed are submitted herewith.

Please charge any fees due in this respect to Deposit Account No. 06-1050.

Respectfully submitted,

Date:

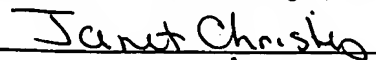
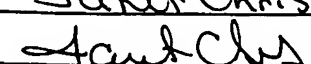
3/10/98

  
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Scott C. Harris  
Reg. No. 32,030

Fish & Richardson P.C.  
4225 Executive Square, Suite 1400  
La Jolla, CA 92037

Telephone: 619/678-5070  
Facsimile: 619/678-5099  
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I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

  
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PATENT OFFICE  
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る事項と同一であることを証明する。

This is to certify that the annexed is a true copy of the following application as filed  
in this Office.

願 年 月 日  
Date of Application:

1997年 1月20日

願 番 号  
Application Number:

平成 9年特許願第022077号

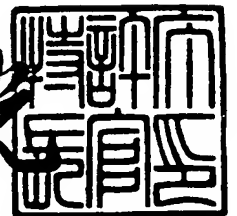
願 人  
Applicant(s):

株式会社半導体エネルギー研究所

1997年11月28日

特 許 庁 長 官  
Commissioner,  
Patent Office

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出証番号 出証特平09-3097781

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